



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Masaki KOMAKI

Serial No.: 09/939,752

Filed: August 28, 2001

For: FUNDAMENTAL CELL, SEMICONDUCTOR INTEGRATED
DEVICE, WIRING METHOD AND WIRING APPARATUS

Confirmation No: 3840

Art Unit: 2815

Examiner: J. Nguyen

Docket No.: 024016-00014

#13/c

Amold

J. McInnis

9/4/03

RESPONSE / AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

August 21, 2003

Sir:

In response to the Office Action dated May 23, 2003, (hereinafter "outstanding Action") with the response time falling within the shortened statutory period, please amend the application as follows:

08/22/2003 SZEWDIE1 00000069 09939752

01 FC:1202

18.00 OP

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- ☒ Check in the amount of **\$ 18.00** for the extra claim fee is attached. Please charge any fee deficiency or credit any overpayment to Deposit Account No. 01-2300. to cover the filing fee is attached.

Respectfully submitted,

Arent Fox Kintner Plotkin & Kahn, PLLC



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